



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Mitsushi FUJIKI**

Group Art Unit: **2823**

Application Number: **10/772,253**

Examiner: **Thanh V. Pham**

Filed: **February 6, 2004**

Confirmation Number: **6491**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE
INCLUDING A LOW-TEMPERATURE LOWER ELECTRODE-
FORMING STEP**

Attorney Docket Number: **042068**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 28, 2007

Sir:

In response to the Office Action dated August 28, 2007, the response date of which having been extended by one month to December 28, 2007, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.